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1. A METHOD OF MANUFACTURING RADIO FREQUENCY (RF) COIL MULTI-DRIVEN RF BASED-VE ION SOURCE									
Title	Inventors	Applicants	Publication number	Earliest priority	IPC	CPC	Publication date	Earliest publication	Family number
A METHOD OF MANUFACTURING RADIO FREQUENCY (RF) COIL MULTI-DRIVEN RF BASED-VE ION SOURCE	JOSHI JAYDEEP [IN] MOULI ROTTI CHANDRA [IN] CHAKRABORTY ARUN KUMAR [IN] BANDYOPADHYAY MAINAK [IN] GAHLAUT AGRAJIT [IN] PATEL MILINDKUMAR [IN] MUVVALA VENKATA NAGARAJU [IN] PARMAR DEEPAK KUMAR [IN] ROTTI CHANDRAMOULI [IN] PATEL MILIND KUMAR [IN]	INSTITUTE FOR PLASMA RES [IN]	EP3553797A1 EP3553797B1	2018-04-13	H01B5/06 H01F27/28 H01F41/10 H01F5/00 H01F5/04 H01J37/08 H01J37/32	B23K9/167 (US) C25D3/38 (US) H01F27/2876 (EP) H01F41/10 (EP) H01J37/3211 (EP) H01F27/16 (EP) H01J2237/08 (EP) H01J37/3211 (US)	2019-10-16 2022-04-20	2019-10-16	062712725

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